AMENDMENTS TO THE CLAIMS:

Please amend the claims as follows:

1. (Currently amended) A semiconductor laser device comprising:

a substrate having a plurality of recessed portions in its principal surface, and

a plurality of rectangular semiconductor laser chips each disposed in one of the recessed

portions,

wherein the semiconductor laser chips are a facet-emitting type in which a laser beam is

emitted from a facet,

plan configurations of the semiconductor laser chips and the recessed portions are

asymmetrical,

the recessed portions are formed so that the respective emission directions of the

semiconductor laser chips are aligned with each other and are substantially parallel to each other

with a distance therebetween, and

a notch, through which a laser-emitting portion of an associated one of the semiconductor

laser chips is exposed, is formed in the substrate to face the laser-emitting portion,

the laser-emitting-portion is formed on the facet in a longitudinal direction of each of the

semiconductor laser chips, and

the laser beam passing through the laser emitting portion is emitted in a same direction as

the longitudinal direction of each of the semiconductor laser chips.

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2-7. (Cancelled)

8. (Currently amended) The device of Claim 1, A semiconductor laser device comprising:

a substrate having a plurality of recessed portions in its principal surface, and
a plurality of semiconductor laser chips each disposed in one of the recessed portions,

wherein the semiconductor laser chips are a facet-emitting type in which a laser beam is emitted from a facet,

in each said semiconductor laser chip, optical output from its front facet is equal to optical output from its rear facet,

the recessed portions are formed so that the respective emission directions of the semiconductor laser chips are aligned with each other, and

a notch, through which a laser-emitting portion of an associated one of the semiconductor laser chips is exposed, is formed in the substrate to face the laser-emitting portion.

9-10. (Cancelled)

- 11. (Currently amended) The device of Claim [[10]] 1, wherein the plan configurations of the semiconductor laser chips vary in accordance with their emission wavelengths.
- 12. (Currently amended) The device of Claim [[10]] 1, wherein the semiconductor laser chips vary in shape in accordance with their optical outputs.

13. (Cancelled)

14. (Currently amended) The device of Claim 13, A semiconductor laser device comprising:

a substrate having a plurality of recessed portions in its principal surface, and

a plurality of semiconductor laser chips each disposed in one of the recessed portions,

wherein a chip electrode is formed on a face of each said semiconductor laser chip which

faces the bottom face of the associated one of the recessed portions,

the recess electrode is [[so]] formed such that an end portion of the recess electrode extends beyond the principal surface of the substrate and so as to be shared by the semiconductor laser chips, and

a notch, through which a laser-emitting portion of an associated one of the semiconductor laser chips is exposed, is formed in the substrate to face the laser-emitting portion.

- 15. (Withdrawn) A method for fabricating a semiconductor laser device, comprising the steps of:
 - (a) forming a plurality of recessed portions in the principal surface of a substrate, and
- (b) spreading a plurality of semiconductor laser elements in the form of chips in a liquid and pouring the semiconductor-laser-element-spread liquid over the principal surface of the substrate, thereby allowing the semiconductor laser elements to be disposed into the respective recessed portions in a self-aligned manner,

wherein the semiconductor laser elements are a facet-emitting type in which a laser beam is emitted from a facet, and

in the step (a), the recessed portions are formed so that the respective emission directions of the semiconductor laser elements are aligned with each other.

16. (Withdrawn) The method of Claim 15, wherein the step (a) includes the step of forming in the substrate a notch through which a laser-emitting portion of an associated one of the semiconductor laser elements is exposed.

17. (Withdrawn) The method of Claim 15, wherein in the step (a), the recessed portions are so formed as to vary in plan configuration in accordance with the shapes of the associated semiconductor laser elements.